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10-046497

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10/9/02

EFS ID: 18559
Application ID: 10046497
Title of Invention: Method for Forming Raised Structures by Controlled Selective Epitaxial Growth of Facet Using Spacer
First Named Inventor: Er-Xuan Ping
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Disclosure Statement

Application Number: 10/046,497
Attorney Docket Number: MTI-31041-A

Method for Forming Raised Structures by Controlled Selective Epitaxial Growth of Facet Using Spacer

First Named Inventor: Er-Xuan Ping

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Date Signed: 20021003

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Attached Files:

us-information-disclosure-statement

MTI31041Aids.xml

Comments:



Electronic Information Disclosure Statement

Method for Forming Raised Structures by Controlled Selective Epitaxial Growth of Facet Using Space

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Application:



10/046497

Confirmation: 8624

Applicant(s): Er-Xuan Ping

Docket

Number:

MTI-31041-A

Group Art Unit: 2814





Examiner: Thao X. Le

search string: (5393681 or 6391692 or 5308782 or 5998248 or 6319782 or 4554570 or 5200352 or 5376562 or 5079180 or 5753555).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	P01	5393681	1995-02-28		Witek et al.	438	164
	P02	6391692	2002-05-21		Nakamura	438	151
	P03	5308782	1994-05-03		Mazure et al.	438	154
	P04	5998248	1999-12-07		Ma et al.	438	231
	P05	6319782	2001-11-20		Nakabayaski	438	300
	P06	4554570	1985-11-19		Jastrzebski et al.	257	331

P07	5200352	1993-04-06		Pfiester	257	344
P08	5376562	1994-12-27		Fitch et al.	438	155
P09	5079180	1992-01-07		Rodder et al.	438	297
P10	5753555	1998-05-19		Hada	117	9

Signature

Examiner Name	Date
/Thao Le/	11/26/2007